



AF 1765

PATENT  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

) Art Unit: 1765

Applicant: Kozo Nakamura

) Confirmation No.: 6736

Serial No.: 09/856,209

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) 1450, on January 16, 2004:

Filed: May 18, 2001

For: **SILICON CRYSTAL AND  
PRODUCTION METHOD FOR  
SILICON SINGLE CRYSTAL  
WAFER**

Examiner: Matthew J. Song

)   
) Gerald T. Shekleton Reg. No. 27,466

**AMENDMENT**

Mail Stop NON FEE AMENDMENT  
Commissioner for Patents  
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Sir:

The Office Action of October 20, 2003 has been carefully reviewed and the following  
amendments and remarks are made in response thereto.